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(71) Applicant (for all designated States except US): CARL-ZEISS SMT AG [DE/DE]; Carl-Zeiss-Strasse 22, 73447 Oberkochen (DE).

(72) Inventors; and

(75) Inventors/Applicants (for US only): SEIFERT, Andreas [DE/DE]; Kreuzberger Weg 4, 73434 Aalen (DE). MELZER, Frank [DE/DE]; Nördlinger Str. 27, 73469 Utzmemmingen (DE). HEISLER, Andreas [DE/DE]; Mozartstrasse 25, 89555 Steinheim (DE). MANN, Heinz [DE/DE]; Prof.-Wagner-Strasse 14, 73431 Aalen (DE). ROMEYN, Gerhard [DE/DE]; Heckenrosenweg 21, 73447 Oberkochen (DE).

(74) Agent: LORENZ, Werner; Alte Ulmer Strasse 2, 89522 Heidenheim (DE).

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Declarations under Rule 4.17:

- as to the identity of the inventor (Rule 4.17(i)) for all designations
- as to applicant's entitlement to apply for and be granted a patent (Rule 4.17(ii)) for the following designations AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NA, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, UZ, VC, VN, YU, ZA, ZM, ZW, ARIPO patent (BW, GH, GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PL, PT, RO, SE, SI, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG)
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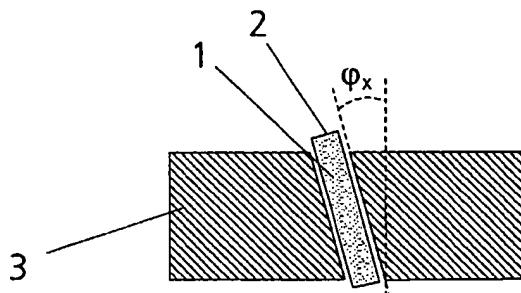
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(54) Title: FACET MIRRORS AND A METHOD FOR PRODUCING MIRROR FACETS

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(57) Abstract: In a method for producing mirror facets (1) for facet mirrors in illuminating devices or projection exposure machines in microlithography by using radiation in the extreme ultraviolet range, individual tilting angles are recessed into an optical surface (2) of the mirror facet (1), preferably a surface with tilting angles relative to a reference surface of the mirror facet (1) is machined into or on said optical surface.